Docket No.: 87391.1000 PATENT/OFFICIAL

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Raymond Payette

Serial No. New Application : Group Art Unit: Unassigned

Filed: April 2, 2004 : Examiner: Unassigned

For: INTERFEROMETRIC MODULATION PIXELS AND MANUFACTURING METHOD TEHEROF

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

No further elaboration is believed necessary. Copies of the documents are submitted herewith in accordance with 37 C.F.R. §1.98(a).

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## **AUTHORIZATION**

This Information Disclosure Statement is being filed before receipt of the first Office Action.

No fee is required. The Commissioner is hereby authorized to charge any additional fees which may be required for this submission, or credit any overpayment to deposit account no. 50-2036.

Respectfully submitted,

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## ATTY. DOCKET NO. SERIAL NO. LIST OF ART CITED BY APPLICANT 87391.1000 Unassigned APPLICANT LIN, Wen-Jian, et al. (PTO-1449) GROUP FILING DATE 4/2/04 Unassigned **U.S. PATENT DOCUMENTS EXAMINER'S** PATENT NO. DATE SUBCLASS NAME **CLASS** FILING DATE **INITIALS** 5,835,255 10 Nov 1998 Miles 359/291 359/578 5 May 1994 В С D Ε F G Н J Κ М Ν 0 Р Q R S FOREIGN PATENT DOCUMENTS **EXAMINER'S** PATENT NO. COUNTRY SUBCLASS DATE **CLASS** Translation **INITIALS** U ۷ W X Υ Ζ AA BB CC DD EE OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.) FF GG НН 11 JJ **EXAMINER** DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.